



2625  
DFW

Attorney Docket: 67,200-435  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Chang Cheng Hung

Serial No.: 09/991,341

Group Art Unit: 2625

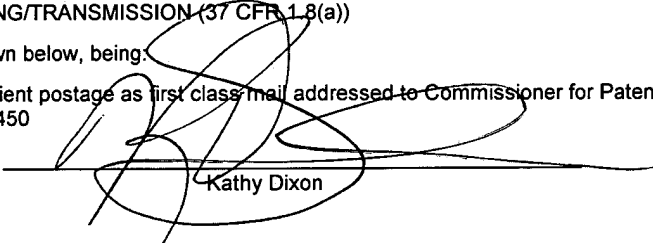
Filed: 11/16/2001

Examiner: Chawan, Sheela C.

For Method for Applying a Defect Finder Mark to a Backend Photomask Making Process

**AMENDMENT IN RESPONSE TO A NON-FINAL OFFICE ACTION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

<p style="text-align: center;">CERTIFICATE OF MAILING/TRANSMISSION (37 CFR 1.8(a))</p> <p>I hereby certify that this correspondence is, on the date shown below, being:</p> <p>-- deposited with the United States Postal Service with sufficient postage as first class mail addressed to Commissioner for Patents at MS Amendment, P.O. Box 1450, Alexandria, VA 22313-1450</p> <p style="text-align: right;"> Kathy Dixon</p> <p>Date: Feb. 2, 2005</p>
---

Sir:

In response to the Office action dated 16 November 2004, rejecting claims 1-20, please amend the above-identified U.S. patent application as follows:

**Amendments to the claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.